

Title (en)
Monitoring system of a ceramics kiln

Title (de)
Anordnung zur Steuerung eines Keramik-Ofens

Title (fr)
Système de contrôle d'un four pour des céramiques

Publication
EP 1500889 A1 20050126 (EN)

Application
EP 04017200 A 20040721

Priority
IT MO20030218 A 20030725

Abstract (en)
Method for monitoring and regulating a ceramics kiln (1) comprises the following phases: picking up at preset intervals of time a sample of ceramic products (4) emerging from the kiln (1); measuring the plan dimensions and the flatness of each of said products (4); checking that said dimensions and said flatness are comprised within preset values; modifying the regulation of the kiln (1) if said dimensions and/or said flatness do not fall within said preset values. <??>Apparatus for monitoring and regulating a ceramics kiln (1) comprises picking up means (5) of ceramic products (4) at the outlet of said kiln (1), cooling means (7) of said ceramic products (4), optical scan means of said ceramic products (4) and monitoring and regulating means (12, 13) of the ceramics kiln (1), operationally connected to said optical scan means (8). <IMAGE>

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Citation (search report)
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